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Applicant: Toru YAMADA, et al.

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For: Vapor Phase Growth Apparatus and Method of Fabricating

Epitaxial Wafer

INFORMATION DISCLOSURE STATEMENT - PTO FORM 1449

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INFORMATION DISCLOSURE STATEMENT - PTO FORM 1449 - Page 2 of 2

| Examiner Signature | /Felisa Hiteshew/ | Date Considered | 09/09/2008 |
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^{*}Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

^{**}Applicant is to place a check mark here if English language translation is attached